



Docket #: 60188-0431

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Akihiko ISHIBASHI, et al. : Confirmation Number: 6491
Serial No.: 10/017,389 : Group Art Unit: 2818
Filed: December 18, 2001 : Examiner: Mai Huong C. Tran
For: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR
FABRICATING SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR
LIGHT EMITTING DEVICE

PATENT

RECEIVED
SEP 23 2003

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 22, 2003, having a three-month shortened statutory period for response set to expire on October 22, 2003, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.